Attorney Docket No.: 021653-002800US Client Ref. No.: I-02-051

PTO/SB/01A (05-03)

Approved for use through 10/31/2002. OMB 0651-0032 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

DECLARATION (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	tion METHOD AND STRUCTURE FOR FABRICATING PATTERNS ON PHASE SHIFT MASK FOR THE MANUFACTURE OF SEMICONDUCTOR WAFERS						
As the below named inventor(s), I/we declare that:							
This declaration is directed to:							
	\boxtimes	The attache	d application, or				
		Application I	No., filed on,				
		as amer	nded on (if appli	cable);			
I/we believe that I/we am/are the original and first inventor(s) of the subject matter which is claimed and for which a patent is sought;							
I/we have reviewed and understand the contents of the above-identified application, including the claims, as amended by any amendment specifically referred to above;							
I/we acknowledge the duty to disclose to the United States Patent and Trademark Office all information known to me/us to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information which became available between the filing date of the prior application and the national or PCT International filing date of the continuation-in-part application.							
All statements made herein of my/our own knowledge are true, all statements made herein on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001, and may jeopardize the validity of the application or any patent issuing thereon.							
FULL NAME OF INVEN	NTOR(S)		, , , , , , , , , , , , , , , , , , , 		t /17 /2.2		
Inventor 1 Chi-Yu	uan Hun	g . /	. /	_ Date:	June / 17 /2003		
Signature:	1-	Yuan	Hang	Citizen of:	Peoples Republic of China		
Inventor 2		-		_ Date:			
Signature:				Citizen of:			
Inventor 3				_ Date:			
Signature:				_ Citizen of:			
Inventor 4				Date:			
Signature:				_ Citizen of:			
☐ Additional inventors are	e being n	amed on form(s	s) attached hereto.				

This collection of information is required by 35 CFR 115 and 37 CFR 1.63. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1 minute to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Unassigned

Chi-Yuan Hung

Herewith

PTO/SB/81 (05-03)
Approved for use through 04/30/2003. OMB 0651-0035
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. **Application Number**

First Nam d Inventor

Filing Date

POWER OF ATTORNEY OR AUTHORIZATION OF AGENT	Title	Patterns on Phase Shift Mask for the Manufacture of Semiconductor Wafers				
	Art Unit	Unassigned				
	Examiner Name	Unassigned				
	Attorney Docket Numb	er 021653-002800US				
I hereby appoint: ☑ Practitioners at Customer Number						
OR		20350 PATENT TRADEMARK OFFICE				
Practitioner(s) named below:						
Name	. Re	Registration Number				
as my/our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.						
Please change the correspondence address for the above-identified application to: The above-mentioned Customer Number. Practitioners at Customer Number						
Practitioners at Customer Number						
☐ Firm <i>or</i> Individual Name						
Address						
Address						
City	State	ZIP				
Country						
Telephone	Fax					
I am the:						
Applicant/Inventor.						
Assignee of record of the entire interest. Se						
Statement under 37 CFR 3.73(b) is enclosed. (Form PTO/SB/96).						
	E of Applicant or Assignee	of Record				
Name Michelle Gon	Michelle Gon					
Signature Signature						
Date 6/11 >003	<u> </u>					
NOTE: Signatures of all the inventors or assignees of reco- forms if more than one signature is required, see below*. *Total of 1 forms are submitted	ord of the entire interest or their re	presentative(s) are required. Submit multiple				

This collection of information is required by 37 CFR 1.31 and 1.33. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 3 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Attorney Docket No. 021653-002800US

STATEMENT UNDER 37 CFR 3.73(b)						
Applicant/Patent Owner: Chi-Yuan Hung						
Application No./Patent No.: Filed/Issue Date:						
Entitled: METHOD AND STRUCTURE FOR FABRICATING PATTERNS ON PHASE SHIFT MASK FOR THE MANUFACTURE OF SEMICONDUCTOR WAFERS						
Semiconductor Manufacturing International Corporation , a						
(Name of Assignee) (Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)						
states that it is:						
1.						
 an assignee of less than the entire right, title and interest. The extent (by, percentage) of its ownership interest is% 						
in the patent application/patent identified above by virtue of either:						
A. An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel, Frame, or for which a copy thereof is attached.						
OR						
B. A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as shown below:						
1. From:						
The document was recorded in the United States Patent and Trademark Office at						
Reel, Frame, or for which a copy thereof is attached.						
2. From: To :						
The document was recorded in the United States Patent and Trademark Office at						
Reel, Frame, or for which a copy thereof is attached.						
3. From: To :						
The document was recorded in the United States Patent and Trademark Office at						
Reel, Frame, or for which a copy thereof is attached.						
☐ Additional documents in the chain of title are listed on a supplemental sheet.						
☑ Copies of assignments or other documents in the chain of title are attached.						
[NOTE: A separate copy (i.e., the original assignment document or a true copy of the original document) must be submitted to Assignment Division in accordance with 37 CFR Part 3, if the assignment is to be recorded in the records of the USPTO. See MPEP 302.8]						
The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.						
6/17/2003 Michelle Gron						
Date Typed or printed name						
Signature						
Chied Legal Officer						
Title						

This collection of information is required by 37 CFR 3.73(b). The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.